## II. SPECIFICATION AMENDMENTS

Please replace the paragraph/section beginning on page 3, line 10, through page 3, line 25 as rewritten below:

roporte services

2 is an exploded view of a semiconductor cassette reducer 20 in accordance with one embodiment of invention. The semiconductor cassette reducer 20 has a substantially U-shaped plate first and a second substantially U-shaped plate 24. A plurality of wafer supports 26, 28, 30, 32 connect the first substantially Ushaped plate 22 to the second substantially U-shaped plate 24. In one embodiment screws 34 and washers 36 are used to attach the U-shaped plates 22, 24 to the wafer supports 26, Retention springs (plurality of retention 30, 32. springs, more than two retention springs, flexible disks) 38 are attached to the first U-shaped plate 22 and the second U-shaped plate 24. In one embodiment, the retention springs 38 are attached using screws 40. In one embodiment, the retention/springs are formed of a rubbery substance that is deformable. When the cassette reducer is placed in the FOUP the retention springs 38 grab the sides of the FOUP. The back two retention springs 38**′** lock into a depression lip 38L in the FOUP. This provides a solid grip for the cassette in FOUP. The